

Client **EMC Technologies (AUS)**

CALIBRATION CERTIFICATE

Object(s) **ET3DV6 - SN:1380**
 Calibration procedure(s) **QA CAL-01.v2
Calibration procedure for dosimetric E-field probes**
 Calibration date: **July 18, 2003**
 Condition of the calibrated item **In Tolerance (according to the specific calibration document)**

This calibration statement documents traceability of M&TE used in the calibration procedures and conformity of the procedures with the ISO/IEC 17025 international standard.

All calibrations have been conducted in the closed laboratory facility: environment temperature 22 +/- 2 degrees Celsius and humidity < 75%.

Calibration Equipment used (M&TE critical for calibration)

Model Type	ID #	Cal Date (Calibrated by, Certificate No.)	Scheduled Calibration
RF generator HP 8684C	US3642U01700	4-Aug-99 (SPEAG, in house check Aug-02)	In house check: Aug-05
Power sensor E4412A	MY41495277	2-Apr-03 (METAS, No 252-0250)	Apr-04
Power sensor HP 8481A	MY41092180	18-Sep-02 (Agilent, No. 20020918)	Sep-03
Power meter EPM E4419B	GB41293874	2-Apr-03 (METAS, No 252-0250)	Apr-04
Network Analyzer HP 8753E	US37390585	18-Oct-01 (Agilent, No. 24BR1033101)	In house check: Oct 03
Fluke Process Calibrator Type 702	SN: 6295803	3-Sep-01 (ELCAL, No.2360)	Sep-03

	Name	Function	Signature
Calibrated by:	Nico Vetterli	Technician	

	Name	Function	Signature
Approved by:	Katja Pokovic	Laboratory Director	

Date issued: July 18, 2003

This calibration certificate is issued as an intermediate solution until the accreditation process (based on ISO/IEC 17025 International Standard) for Calibration Laboratory of Schmid & Partner Engineering AG is completed.

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Probe ET3DV6

Additional Conversion Factors

SN:1380

Manufactured:	August 16, 1999
Last calibration:	November 9, 2002
Add ConvF:	July 18, 2003

Calibrated for DASY Systems

(Note: non-compatible with DASY2 system!)

DASY - Parameters of Probe: ET3DV6 SN:1380

Sensitivity in Free Space

NormX	1.67 $\mu\text{V}/(\text{V}/\text{m})^2$
NormY	1.57 $\mu\text{V}/(\text{V}/\text{m})^2$
NormZ	1.73 $\mu\text{V}/(\text{V}/\text{m})^2$

Diode Compression

DCP X	90	mV
DCP Y	90	mV
DCP Z	90	mV

Sensitivity in Tissue Simulating Liquid

Head **2450 MHz** $\epsilon_r = 39.2 \pm 5\%$ $\sigma = 1.80 \pm 5\% \text{ mho/m}$

Valid for f=2400-2500 MHz with Head Tissue Simulating Liquid according to EN 50361, P1528-200X

ConvF X	4.8 $\pm 9.5\%$ (k=2)	Boundary effect:
ConvF Y	4.8 $\pm 9.5\%$ (k=2)	Alpha 1.10
ConvF Z	4.8 $\pm 9.5\%$ (k=2)	Depth 1.76

Body **2450 MHz** $\epsilon_r = 52.7 \pm 5\%$ $\sigma = 1.95 \pm 5\% \text{ mho/m}$

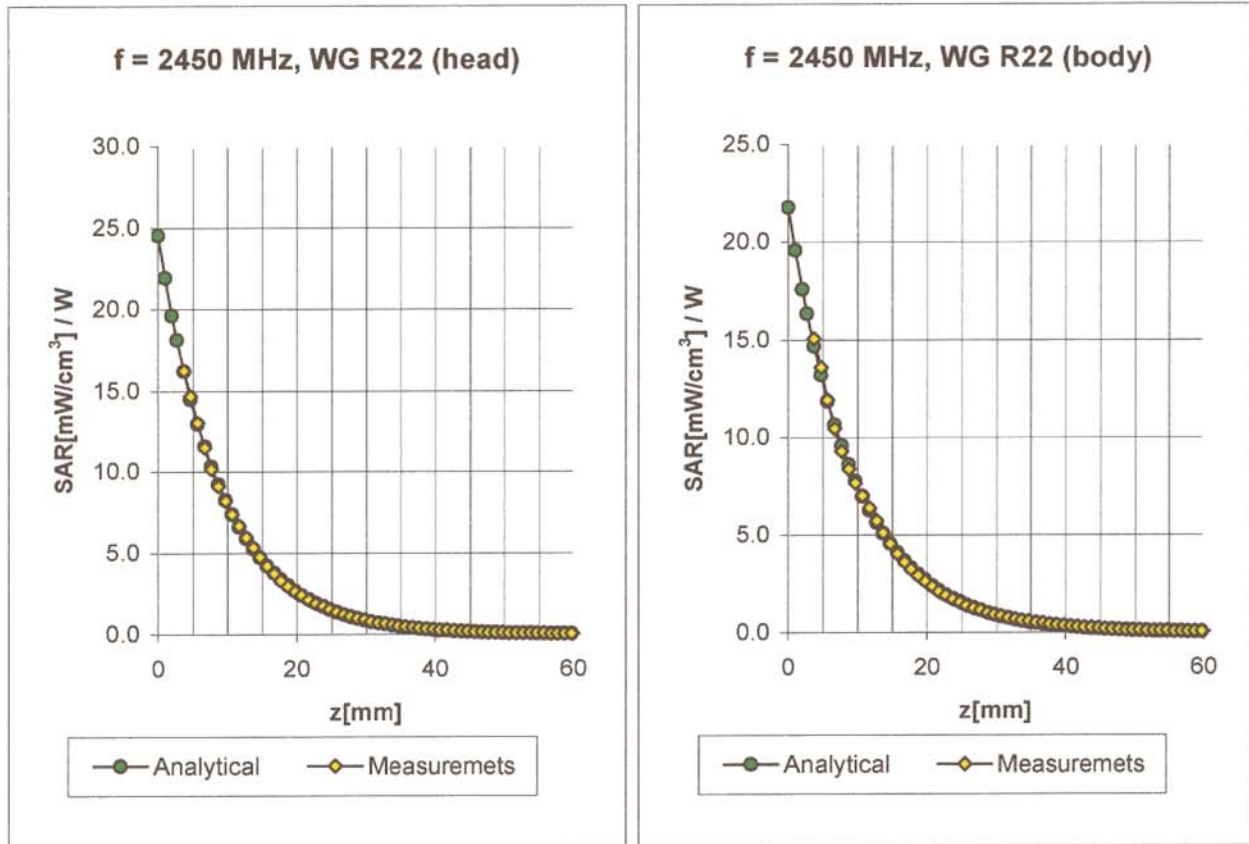
Valid for f=2400-2500 MHz with Body Tissue Simulating Liquid according to OET 65 Suppl. C

ConvF X	4.5 $\pm 9.5\%$ (k=2)	Boundary effect:
ConvF Y	4.5 $\pm 9.5\%$ (k=2)	Alpha 1.52
ConvF Z	4.5 $\pm 9.5\%$ (k=2)	Depth 1.42

Sensor Offset

Probe Tip to Sensor Center	2.7	mm
Optical Surface Detection	1.5 \pm 0.2	mm

Conversion Factor Assessment



Head 2450 MHz $\epsilon_r = 39.2 \pm 5\%$ $\sigma = 1.80 \pm 5\%$ mho/m

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